

**A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL**

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

1/7

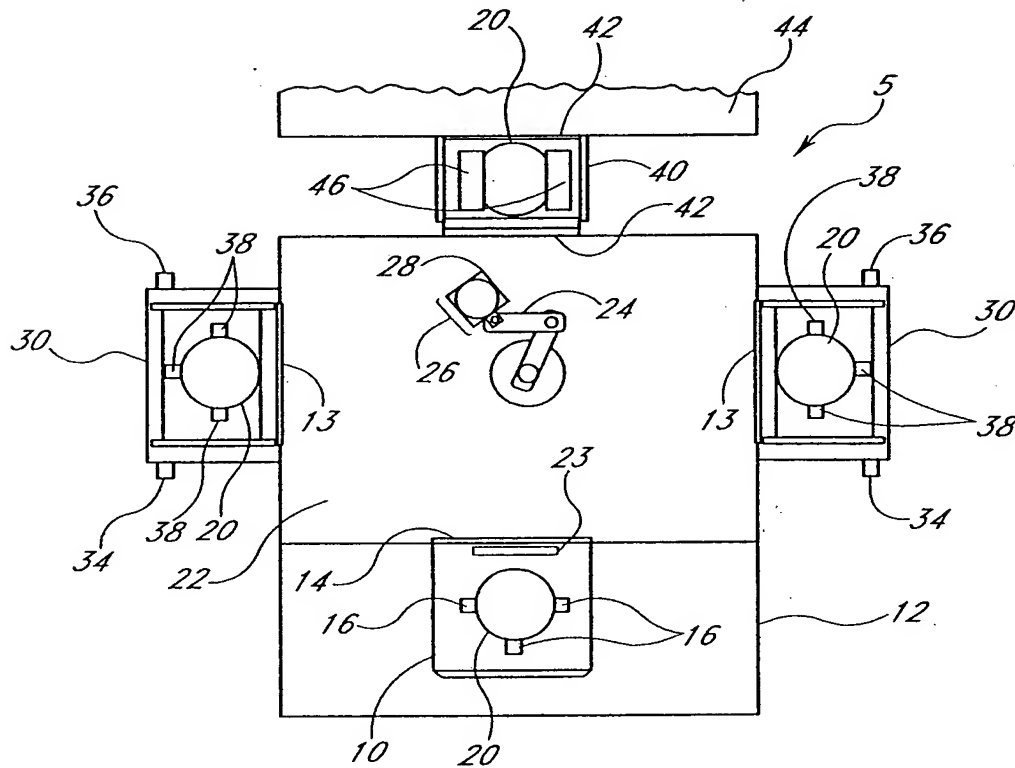


FIG. 1

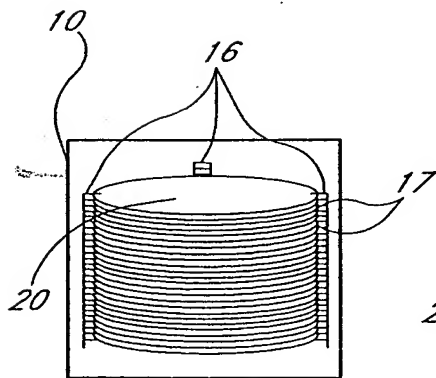


FIG. 2A

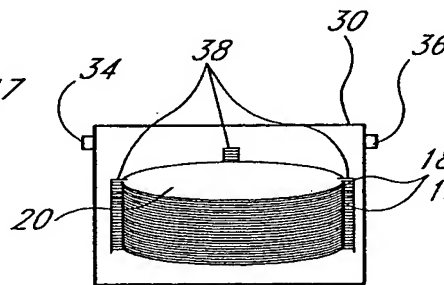


FIG. 2B

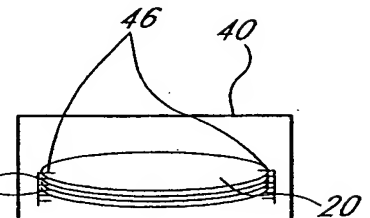


FIG. 2C

A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

FIG. 3A

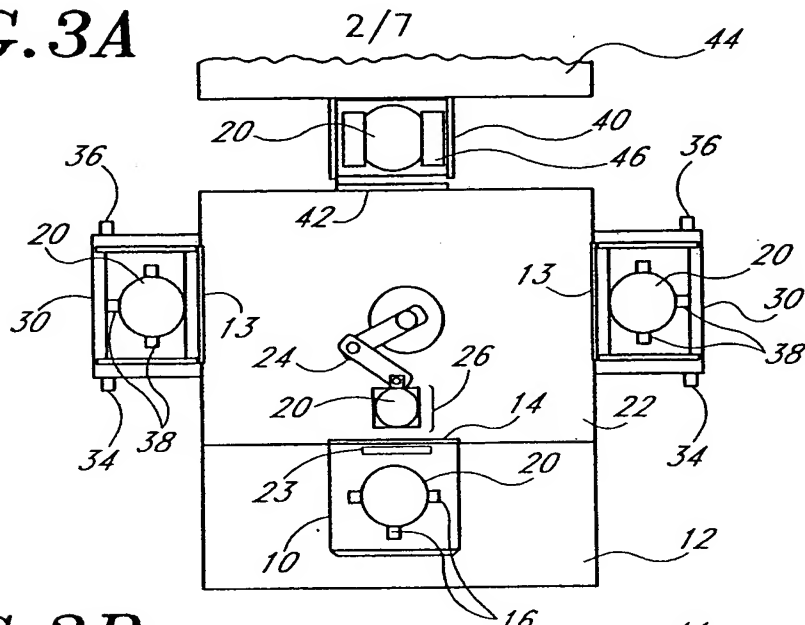


FIG. 3B

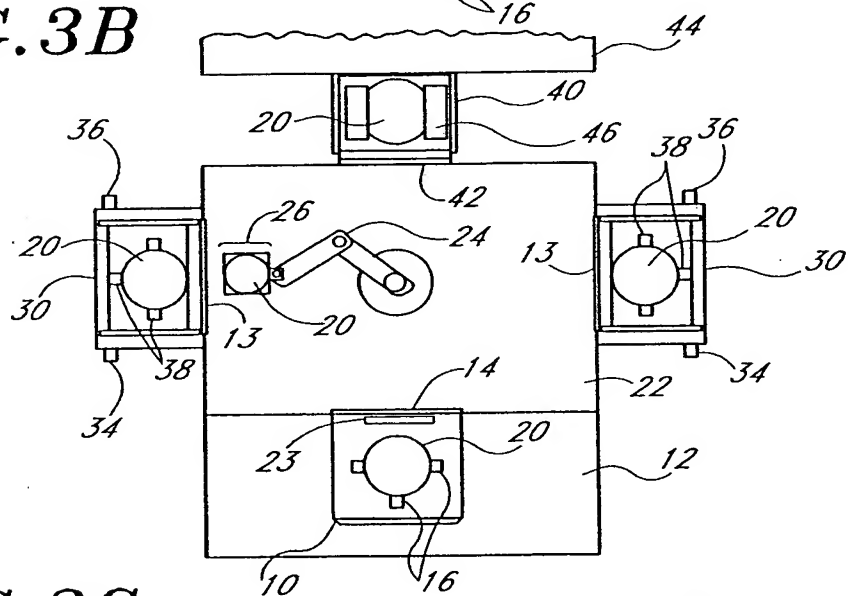
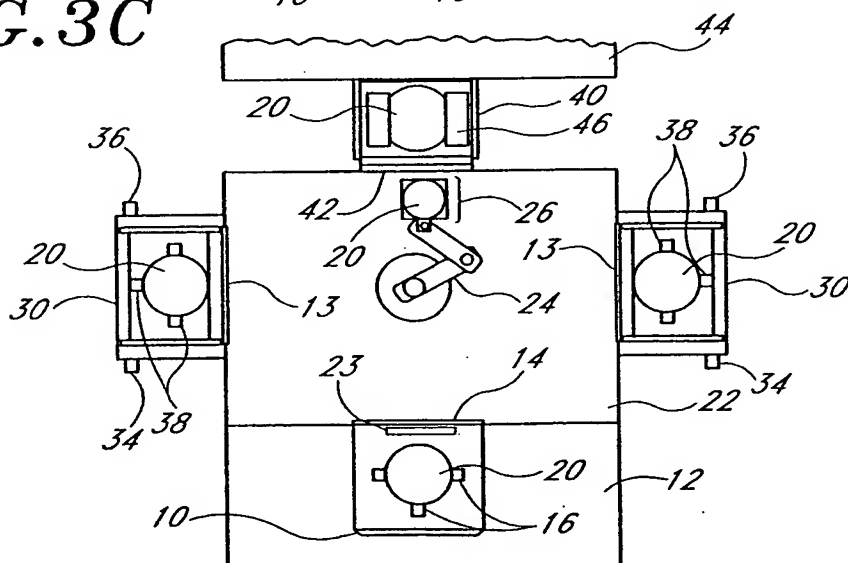


FIG. 3C



A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

3/7

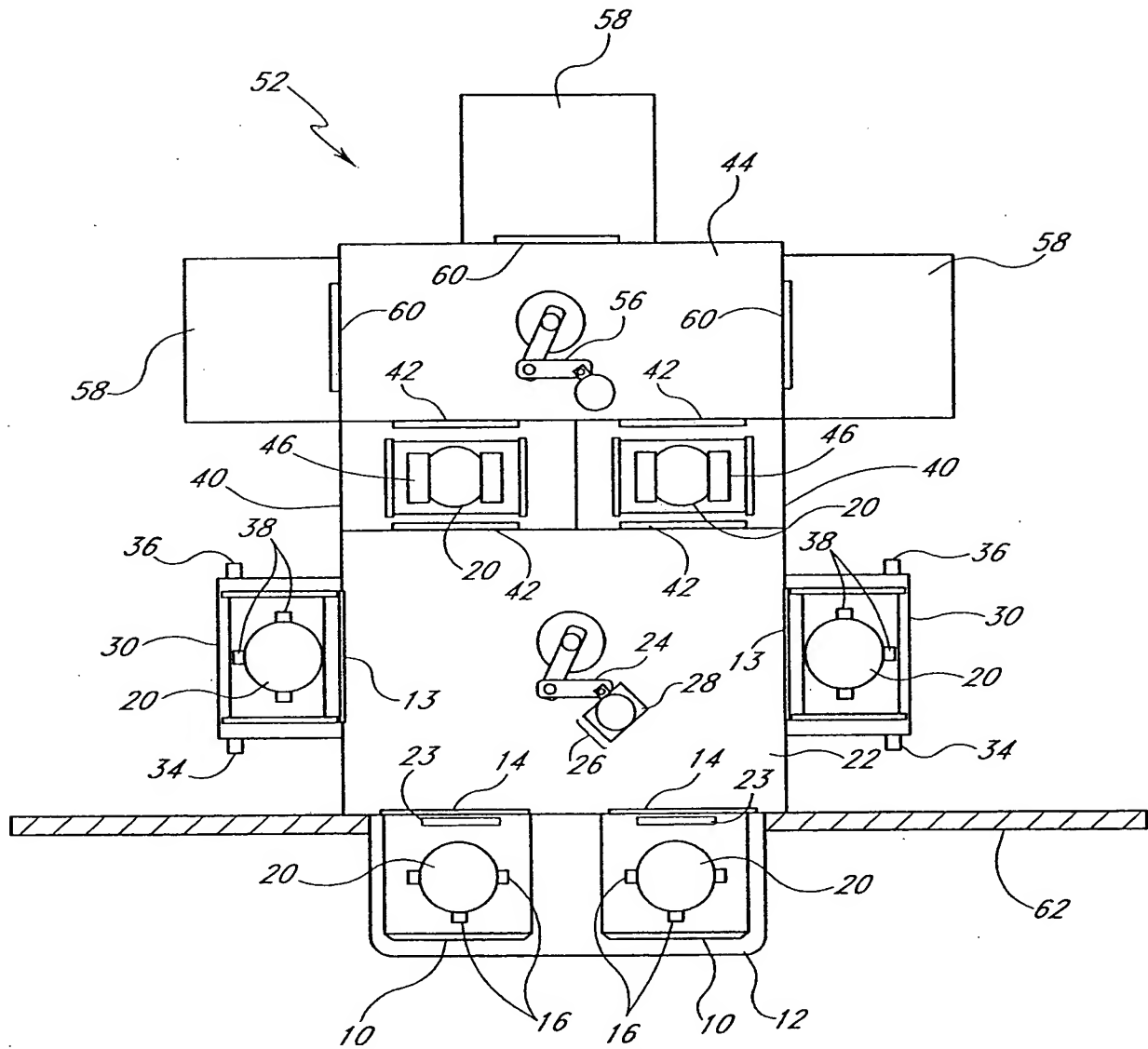


FIG. 4

Aggarwal et al.

4/7

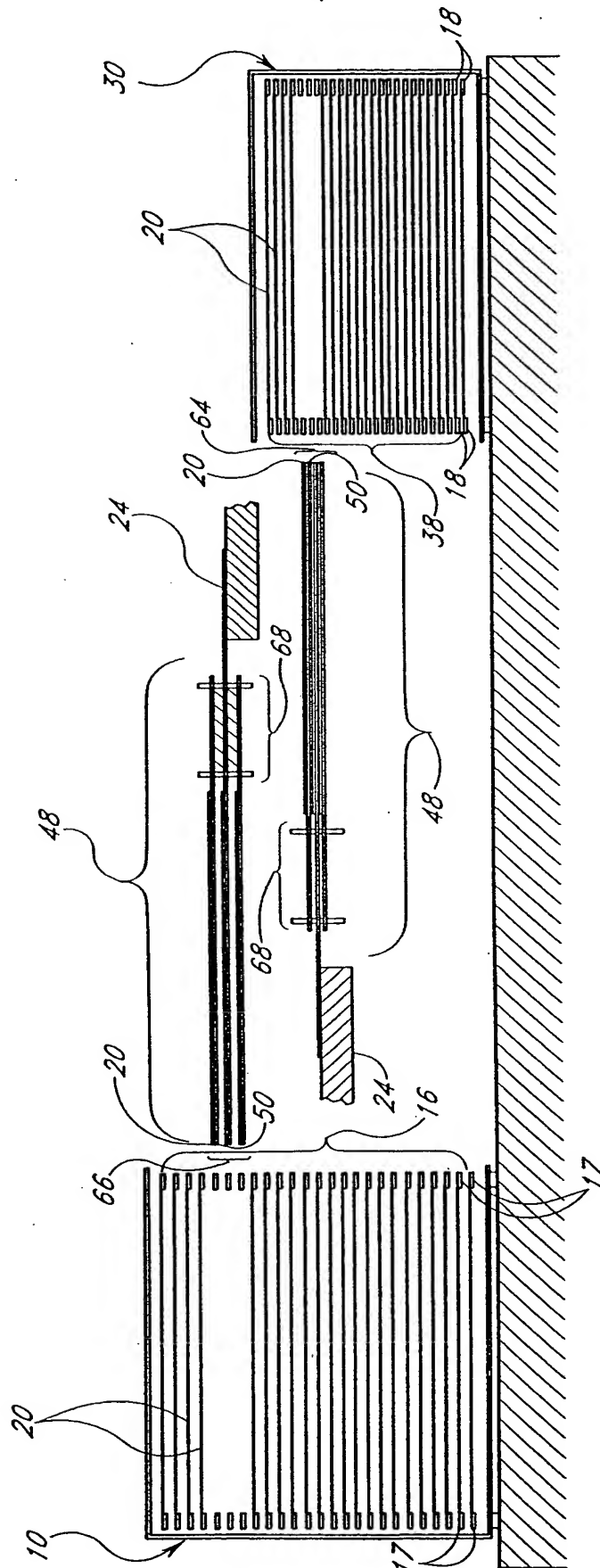


FIG. 5

A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

5/7

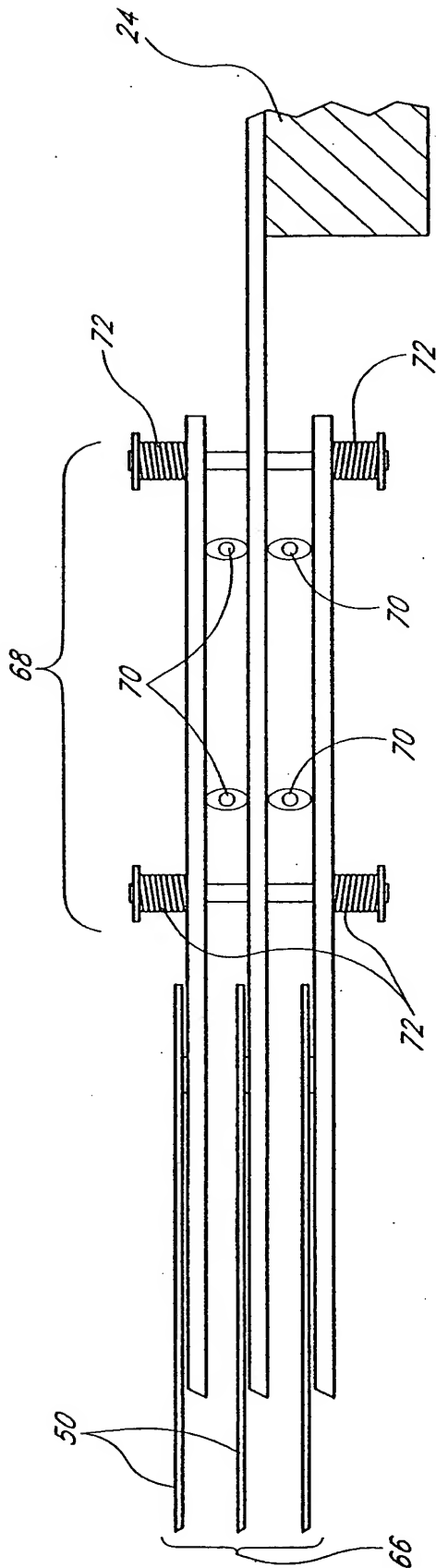


FIG. 6A

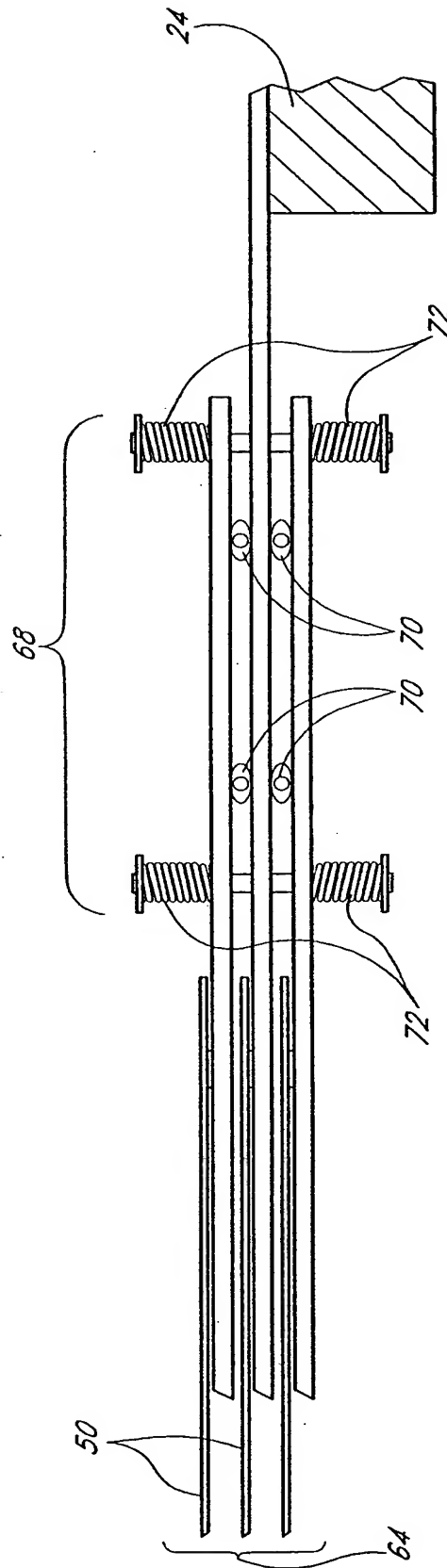


FIG. 6B

A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

6/7

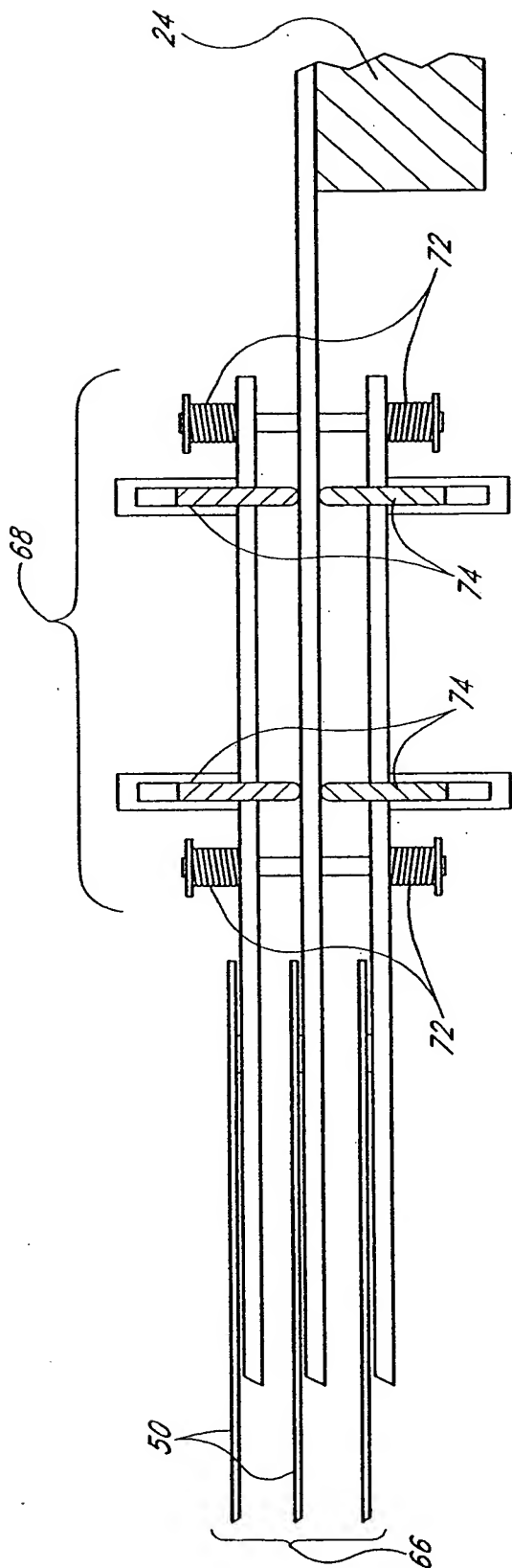


FIG. 7A

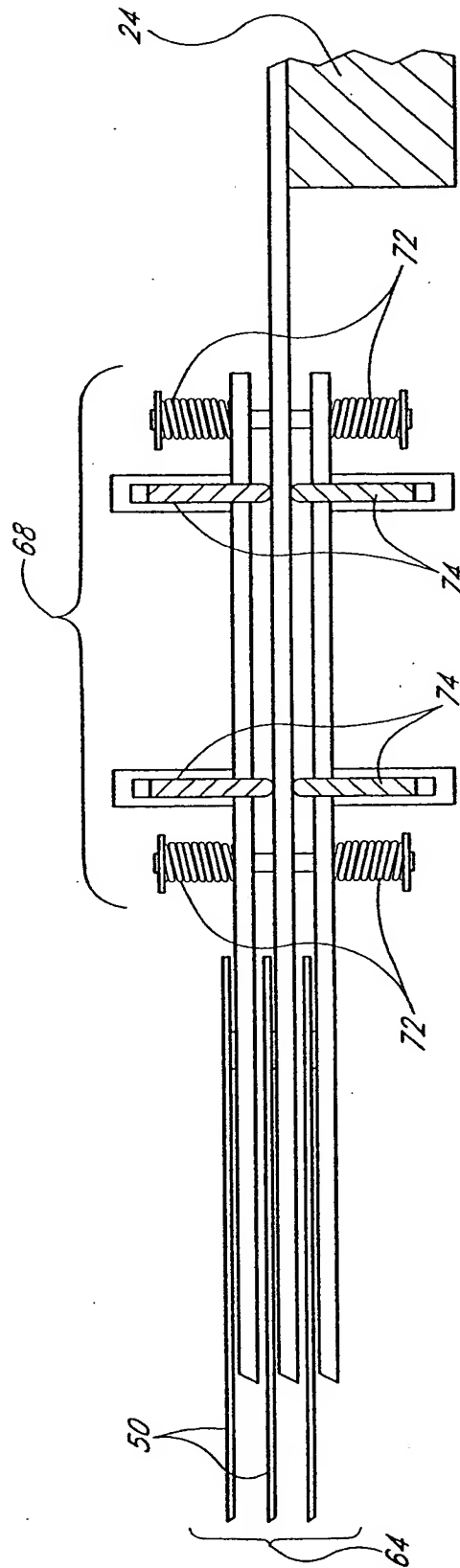


FIG. 7B

*A SYSTEM FOR THE IMPROVED HANDLING OF WAFERS
WITHIN A PROCESS TOOL*

Aggarwal et al.

Appl. No.: Unknown Atty Docket: ASMEX.358DV1

7/7

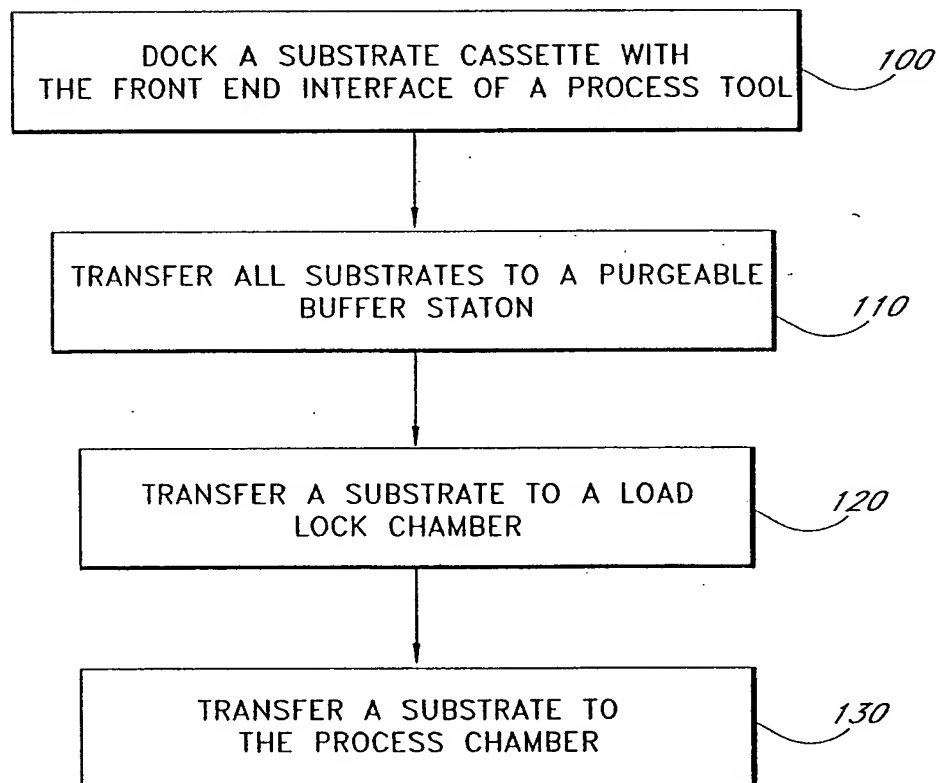


FIG. 8